U.S. Serial No. 10/564,742

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re patent application of: Daisuke ENDO, et al.

Serial No.: 10/564,742 Group Art Unit: 1729

Filing Date: January 17, 2006 Examiner: Jacob B. Marks

For: POSITIVE ACTIVE MATERIAL, PROCESS FOR PRODUCING THE SAME,

AND POSITIVE ELECTRODE FOR LITHIUM SECONDARY BATTERY AND

LITHIUM SECONDARY BATTERY EACH EMPLOYING THE SAME

Honorable Commissioner for Patents Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicants' duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following documents cited in the Japanese Office Action dated September 6, 2011 in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner (with English abstracts). Further, an English language translation of the Office Action is attached.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the reference, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION					APPLICANT(S) 10/564,742			
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INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) OCT 0 7 2011 &  *EXAMINER INITIAL DOCUMENT NUMBER DATE					FILING DATE		GROUP ART UNIT	
					January	17, 2006		1729
			PADENIA	PATENT	DOCUMENTS		·	
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U.S. PATENT APPLICATION PUBLICATIONS								
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			FORE	IGN PATE	ENT DOCUMENTS			
	DOCUMENT I	DOCUMENT NUMBER			COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
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	ОТН	ER DOCUMEN	NTS (Includir	ng Author	, Title, Date, Per	tinent Pages, Et	c.)	
	Japanese (	Office Action	dated Septen	nber 6, 20	011 (with English	translation).		
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EXAMINER					DATE CONSIDERED			

Form PTO-A820 (also form PTO-1449) P09C/REV04

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